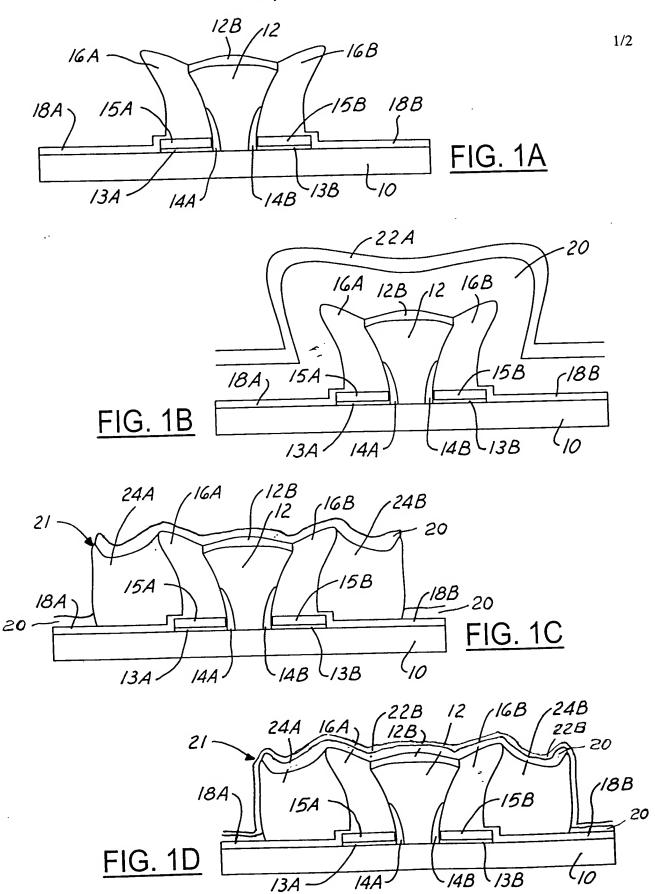
Inventor: Hsiu Ouyang

Serial No.: To Be Assigned Filed: Herewith

For: Etching Method for Forming a Square Cornered Polysilicon Wordline Electrode

Attorney Doc. No.: 67,200-1097



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